IIIL 2 5 2001

INFORMATION DISCLOSURE TETEL **CITATION** PTO-1449

Ats. Docket No. 010328

Serial No. 09/816,784

Applicant(s):

Kazuhiro HATTORI

Filing Date: March 26, 2001

Group Art Unit: Not Yet Assigned

## **U.S. PATENT DOCUMENTS**

Examiner Initial		Document No.	Name	 Date	Class	Subclass	Filing Date (If appropriate)
	AA						
	AB						. 11
	AC						
	AÐ						
	AE						

## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
LY	AF	8-253881	10/01/96	Japan	Abstract
	AG				
	AH	1/4			,
	AI				
	AJ				

## OTHER DOCUMENTS

LV	AK	-IEEE Transaction on Magnetics, Vol. 32, pp4448-4451, September, 1996, "Ultramicro Fabrications on Fe-Ni Alloys Using Electron-Beam Writing and Reactive- Ion Etching.	
Examiner /	An/	Date Considered 3/26/2003	